

<b>Notice of References Cited</b>	Application/Control No. 10/037,337	Applicant(s)/Patent Under Reexamination COPELAND ET AL.	
	Examiner Benjamin C. Lee	Art Unit 2632	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5371490	12-1994	Martinides	340/572.4
	B	US-5499017	03-1996	Beigel	340/572.1
	C	US-5561430	10-1996	Knebelkamp	342/44
	D	US-5453747	09-1995	D'Hont et al.	342/42
	E	US-6014111	01-2000	Johannessen	343/788
	F	US-5625366	04-1997	D'Hont	343/718
	G	US-5220338	06-1993	Matsushita	343/787
	H	US-3665449	05-1972	Elder et al.	340/572.1
	I	US-6172608B1	01-2001	Cole	340/572.1
	J	US-6304182B1	10-2001	Mori e al.	340/572.1
	K	US-6351215B2	02-2002	Rodgers et al.	340/572.1
	L	US-6307517B1	10-2001	Lee	343/741
	M	US-6268723B1	07-2001	Hash et al.	324/243

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.